INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

1 of 1

Complete if Known				
Application Number	10/561,156			
Filing Date	12-16-05			
First Named Inventor	Bjorn Norhammar, et al;			
Group Art Unit	2464			
Examiner Name	Ben H. Liu			
Attorney Docket Number	9563-10			

	II C DATEM	TS AND PATENT P	UDLICATIONS

Examiner	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited	Date of Publication of Cited
Initials*		Number	Kind Code (if known)	Document	Document MM-DD-YYYY
		US			
		US-			

U.S. PATENT APPLICATIONS

initials*	Cite No.	U.S. Serial No.	Name of Applicant of Cited Document	Document MM-DD-YYYY	ı
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Examiner Initials*	Cite No.	Foreign Patent Document		ument	Name of Patentee or Applicant of Cited	Date of	Translation
		Office	Number	Kind Code (if known)	Document	Publication of Cited Document MM-DD-YYYY	
	1.	JP	2002-111998		Toshiba Corp.	04-12-2002	Abstract Only
	2	JP	2002-027136		Azumi Haruyuki/Washimi Hideki	01-25-2002	Abstract Only
	3	JP	2002-175069		NEC Microsystems Ltd.	06-21-2002	Abstract Only
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	7	JP	10-285457		SONY Corp.	10-23-1998	Abstract
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OTHER NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city end/or country where published	Т		

Examiner Signature	/Ben Liu/	Date Considered	12/07/2010
	/Dell Liu/		12/01/2010

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.